

**Notice of References Cited**

Application/Control No.

10/086,277

Applicant(s)/Patent Under  
Reexamination  
KALUSKAR ET AL

Examiner

Jean M Corrielus

Art Unit

2172

Page 1 of 1

**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-5,875,334	02-1999	Chow et al.	717/141
	B	US-6,457,007	09-2002	Kikuchi et al.	707/10
	C	US-6,269,373	07-2001	Apte et al.	707/10
	D	US-6,598,041	07-2003	Bernal et al.	707/3
	E	US-6,643,637	11-2003	Chen et al.	707/2
	F	US-6,694,305	02-2004	Bernal et al.	707/2
	G	US-6,665,678	12-2003	Ching Chen et al.	707/100
	H	US-6,721,731	04-2004	Cornwell et al.	707/3
	I	US-5,758,144	05-1998	Eberhard et al.	707/2
	J	US-5,734,884	03-1998	Eberhard et al.	707/2
	K	US-5,963,742	10-1999	Williams, Gerald S.	717/143
	L	US-5,615,359	03-1997	Yung, Alex	707/10
	M	US-			

**FOREIGN PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

**NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	
	V	
	W	
	X	

\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)  
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.

EC